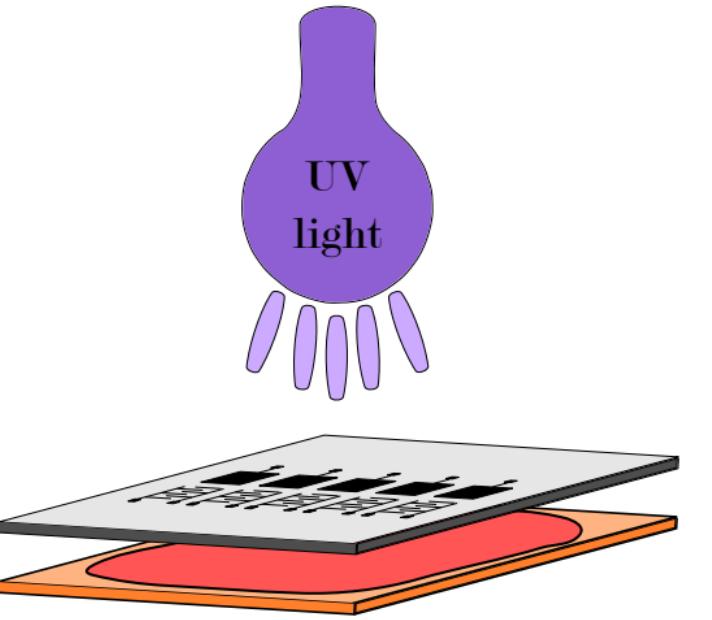
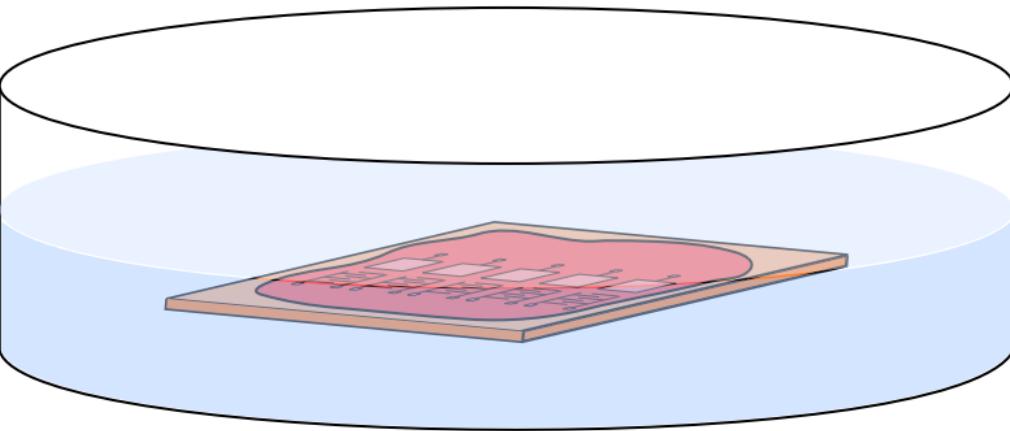


Photoresist  
deposition



UV light  
exposure



Development

